

SEP 25 2006

501.43163X00 / 340200902US01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): SHIBATA, et al.
Serial No.: 10/699,934
Filed: November 4, 2003
For: METHOD AND APPARATUS FOR INSPECTING DEFECTS
Group: 2877
Examiner: T. Ton
Conf. No.: 3889

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

September 25, 2006

Sir:

In response to the Office Action dated April 25, 2006, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Specification**Amendments to the Claims****Amendments to the Drawings**

Remarks are included following the amendments